



CERTIFICATE OF MAILING

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Pamela L. Patrick

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#9/Election
w/ Patent A
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/580,485) Art Unit: 2813
Filed: May 30, 2000) Examiner: A. Sarkar
For: METHODS FOR MANUFACTURING AN ELECTRO-) Date: February 12, 2001
OPTICAL DEVICE)

RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner of Patents and Trademarks
Washington, D. C. 20231

Sir:

In response to the election requirement in the Office Action of December 12, 2000,
Applicants respond as follows:

IN THE CLAIMS:

Please add new claims 30-35 as follows:

--30. A method according to claim 1, further comprising the step of:
forming an insulating film covering the plurality of TFTs,
wherein an uppermost layer of the insulating film is capable of preventing penetration of
an alkaline metal.

31. A method according to claim 2, further comprising the step of:
forming an insulating film covering the plurality of TFTs,

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